

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner:

M. Smith

Filed: February 22, 2000

Docket No.:

104788

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING

DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

SUPPLEMENTAL AMENDMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

As a supplement to the Amendment filed on <u>July 15, 2002</u>, and further to the personal interview between Applicant's representative and Examiner Smith conducted on September 10, 2002, please further amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claims 1, 12 and 15 as follows:

1. (Twice Amended) A method of manufacturing a semiconductor device comprising:

placing a semiconductor assembly in which a semiconductor chip is secured to a die pad of a lead frame in a cavity of a mold;

applying a pressure to the semiconductor assembly by at least one support pin so as to cause a stress in the lead frame;

sealing the semiconductor assembly with a resin injected into the cavity from a resin injection port of the mold, the pressure applied by the at least one support pin